

**Docket #:** S10-333

# Manufacturing Method for Synthetic Gecko-Inspired Adhesives

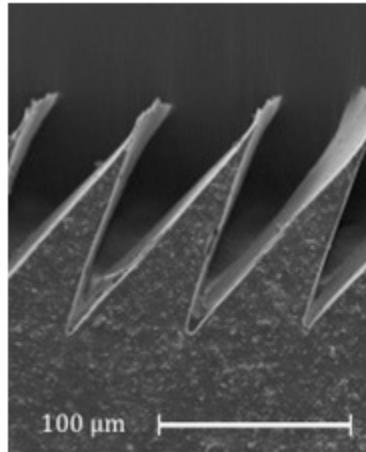
Stanford researchers have developed a new manufacturing method for creating inexpensive, directional dry adhesive materials, suitable for applications such as climbing robots, human climbing and manufacturing applications. This method is more controllable, more repeatable and has a higher yield than current lithographic methods while producing arrays of features with similar quality and performance.

This invention is an advancement of the technology presented in [S06-091 "StickyBot - Climbing with dry adhesives"](#) developed by Prof. Cutkosky's research team at the Stanford Biomimetics and Dexterous Manipulation Lab.

## **Figures:**



A custom end-effector using the adhesives being used to support a large solar panel.



### **Stage of Research:**

- Prototype tested which showed strong performance, particularly on glass
- Suspension developments allow for the use of large areas of adhesives to support large loads (>100lbs)
- Future research to enhance performance on rougher surfaces

## **Applications**

- Dry adhesives have many applications, including **climbing humans and robots, medical devices and manufacturing processes involving the handling of delicate or sensitive materials.**

## **Advantages**

- **Less expensive and more controllable** than existing lithographic processes for making similar molds
- Allows **greater flexibility** with respect to the micro-scale feature geometry, mold size, and mold material
- **Better performance** than previous methods

## **Publications**

- [US Patent Application 20120295068](#)
- Day, P., Eason, E., Esparza, N., Christensen, D., and Cutkosky, M., ["Micro-Wedge Machining for the Manufacture of Directional Dry Adhesives,"](#) ASME J. Micro

## Patents

- Published Application: [20120295068](#)
- Published Application: [20160046043](#)
- Issued: [9,908,266 \(USA\)](#)

## Innovators

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